



BOX AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINER GROUP 2851

03560.002758

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
RYUICHI EBINUMA, ET AL.) Examiner: Hung Nguyen
Application No.: 09/817,018) Group Art Unit: 2851
Filed: March 27, 2001)
For: SUPPORTING STRUCTURE OF OPTICAL) September 22, 2003
ELEMENT, EXPOSURE APPARATUS)
HAVING THE SAME, AND MANUFACTUR-)
ING METHOD OF SEMICONDUCTOR DEVICE:

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Alexandria, Virginia 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Official Action dated June 23, 2003, please amend the
above-identified application as follows.